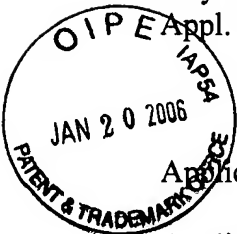


Atty. Docket No.: MXIC 1516-1

Appl. No. 10/721,605

PATENT

AFH
EFV



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chih-Hao WANG *et al.*

Application No.: 10/721,605

Filed: 25 November 2003

Title: **Method for forming oxide on ONO structure**

)
) Examiner: Donghee KANG
)
) Group Art Unit: 2811
)
) Date: January 17, 2006.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: MS AF, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 17, 2006.

Signed


Bill Kennedy

MAIL STOP AF
COMMISSIONER FOR PATENTS
P.O BOX 1450
ALEXANDRIA, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office action mailed 14 July 2005, kindly amend the application as follows.

Amendments to the claims are reflected in the **Listing of Claims** which begins on page 2 of this paper.

Remarks begin on page 13 of this paper.